



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

July 28, 2003

Applicants : Bruce M. WARNES et al.

For : CHEMICAL VAPOR DEPOSITION APPARATUS AND METHOD

Serial No. : 09/950 012

Group: 1762

Filed : Sept. 10, 2001

Examiner: Leung

Confirmation No. 9232

Commissioner for Patents

P.O. Box 1450

Arlington, VA 22313-1450

SUPPLEMENTAL IDS

Dear Sir:

Applicants wish to advise the examiner of copending application Serial No. 09/950 013 which relates to chemical vapor deposition apparatus and method and which has common filing date, inventorship, and assignee with this application. A copy of the application Serial No. 09/950 013 is enclosed. A Form 1449 is enclosed as well.

Applicants petition and ask the examiner to consider the copending application Serial No. 09/950 013. The Commissioner is authorized to charge any fee for the petition to my deposit account No 20-1124.

Respectfully submitted,

Edward J. Timmer Reg. No. 27,402

enclosure: Postal card

CERTIFICATE OF MAILING

I hereby certify that this correspondence and enclosures are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents
P.O. Box 1450, Arlington, VA 22313-1450, on July 28, 2003.

Edward J. Timmer

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